

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Shoji MIYAZAKI et al. : Attn: BOX PCT  
Serial No. NEW : Docket No. 2001-0989A  
Filed July 13, 2001 :

BIOSENSOR, THIN FILM ELECTRODE  
FORMING METHOD, QUANTIFICATION  
APPARATUS, AND QUANTIFICATION  
METHOD

[Corresponding to PCT/JP00/08012  
Filed November 14, 2000]

3/A  
C7.  
1/7/02

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents,  
Washington, DC 20231

Sir:

Prior to examination of the above-referenced U.S. patent application please amend the application as follows:

IN THE SPECIFICATION

Please amend the specification as follows:

Please replace the paragraph beginning at page 15, line 21, to line 25, with the following rewritten paragraph:

According to claim 18 of the present invention, in the biosensor as defined in any of Claims 1 to 17, at least one or all of the first slits, the second slits, the third slits, and the fourth slits are formed by processing the electrical conductive layer by a laser.

TOP SECRET

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